12 March 2004

Updated Search

DB Time stamp L Number Hits Search Text 2002/03/07 136/\$.ccls. and (diffraction adj grating) 35 USPAT; US-PGPUB; 12:24 EPO: JPO: DERWENT 2002/03/07 50 136/252,255,256,259.ccls. and grating USPAT; 15:01 US-PGPUB; EPO; JPO; DERWENT 136/252,255,256,259.ccls. and grating and (reactive 2002/03/07 USPAT; 12:38 adj ion adj etching) US-PGPUB; EPO; JPO; DERWENT 136/252,255,256,259.ccls. and (reactive adj ion adj 2002/03/07 16 USPAT: 15:02 etching) US-PGPUB; EPO; JPO; DERWENT 136/252,255,256,259,261.ccls. and (reactive adj ion 2002/03/07 17 USPAT; adj etching) US-PGPUB; 15:06 EPO; JPO; DERWENT 14 438/71,72,57,65.ccls. and (solar or photovoltaic or USPAT; 2002/03/07 photodetector) and grating US-PGPUB; 15:09 EPO; JPO; DERWENT (438/71,72,57,65.ccls. and (reactive adj ion adj 2002/03/07 USPAT; etching)) and (438/71,72,57,65.ccls. and grating) US-PGPUB; 15:16 EPO; JPO; DERWENT 32 438/71,72,57,65.ccls. and (reactive adj ion adj 2002/03/07 USPAT; 15:36 etching) US-PGPUB; EPO; JPO; DERWENT zaidi.in. and (136/\$.ccls. or 257/\$.ccls. or USPAT: 2002/03/07 438/\$.ccls.) US-PGPUB; 15:20 EPO; JPO; DERWENT 257/436,184,466.ccls. and (reactive adj ion adj 2004/03/12 56 USPAT: etching) U5-PGPUB; 10:42 EPO; JPO; DERWENT 10 257/436,184,466.ccls. and (reactive adj ion adj 2002/03/07 USPAT; etching) and grating 15:36 U5-PGPUB; EPO: JPO: DERWENT 14 (136/\$.ccls. or 257/\$.ccls. or 438/\$.ccls.) and 2002/03/08 USPAT; ruby.in. US-PGPUB; 08:50 EPO; JPO; DERWENT 2853 (136/\$.ccls. or 257/\$.ccls. or 438/\$.ccls.) and (nitric 2002/03/08 USPAT; adj acid) US-PGPUB; 08:54 EPO; JPO; DERWENT

-	389	(136/\$.ccls. or 257/\$.ccls. or 438/\$.ccls.) and (nitric adj acid) and (chemical adj etching)	USPAT; US-PGPUB;	2002/03/08 08:55
			EPO; JPO; DERWENT	
-	102	(136/\$.ccls. or 257/\$.ccls. or 438/\$.ccls.) and (nitric adj acid) and (chemical adj etching) and (koh or (potassium adj hydroxide))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/03/08 08:56
-	29	(136/\$.ccls. or 257/\$.ccls. or 438/\$.ccls.) and (nitric adj acid) and (wet adj chemical adj etching) and (koh or (potassium adj hydroxide))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/03/08 08:59
-	9	(136/\$.ccls. or 257/\$.ccls. or 438/\$.ccls.) and (wet adj chemical adj etching) and ((potash or koh or (potassium adj hydroxide)) same (nitric adj acid))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/03/08 09:09
-	25	(US-6350945-\$ or US-5810945-\$ or US-4818337-\$ or US-4493942-\$ or US-4536608-\$ or US-4482779-\$ or US-4482778-\$ or US-4419533-\$ or US-4379944-\$ or US-6307145-\$ or	USPAT; US-PGPUB; EPO	2002/03/08 12:36
-	2	US-4556790-\$ or US-4555622-\$ or US-4497974-\$ or US-4377722-\$ or US-4350561-\$ or US-4315097-\$ or US-6091021-\$ or US-5932114-\$ or US-5035770-\$ or US-6329296-\$ or US-4989972-\$ or US-5492859-\$ or US-5277748-\$).did. or (US-20010039101-\$).did. or (WO-9214270-\$).did. ((US-6350945-\$ or US-5810945-\$ or US-4818337-\$ or US-4493942-\$ or US-4536608-\$ or US-4482779-\$ or US-4482778-\$ or US-4419533-\$ or US-4379944-\$ or US-6307145-\$ or US-437974-\$ or US-4556790-\$ or US-455622-\$ or US-4497974-\$ or US-4377722-\$ or US-4350561-\$ or US-4315097-\$ or US-6091021-\$ or US-5932114-\$ or US-5035770-\$ or US-6329296-\$ or US-4989972-\$ or US-5492859-\$ or US-5277748-\$).did. or (US-20010039101-\$).did. or (WO-9214270-\$).did.) and blazed	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/03/08 12:51
-	1	136/252,255,256,259,261.ccls. and (gas adj source adj doping)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/03/08 12:54
-	1	136/\$.ccls. and (gas adj source adj doping)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/03/08 13:08
-	0	136/\$.ccls. and fahrenbruch.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/03/08
-	163	136/252,255,256,259,261.ccls. and (ion adj implantation)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/03/08 13:13

	00	12/ /252 255 25/ 250 2/1     //:	HCDAT.	2002/02/08
] -	90	136/252,255,256,259,261.ccls. and ((ion adj	USPAT;	2002/03/08
		implantation) same junction)	US-PGPUB;	13:20
			EPO; JPO;	
	0.1	424,050,055,050,044, 1, 1,44	DERWENT	0000/00/00
-	21	136/252,255,256,259,261.ccls. and ((annealing or	USPAT;	2002/03/08
		annealed) with oxygen)	US-PGPUB;	13:21
			EPO; JPO;	
	_		DERWENT	
-	27	(US-4989972-\$ or US-6350945-\$ or US-6329296-\$	USPAT;	2002/03/08
		or US-6091021-\$ or US-6307145-\$ or US-5932114-\$	US-PGPUB;	14:07
		or US-5810945-\$ or US-5492859-\$ or	EPO	
		US-5277748-\$ or US-5035770-\$ or US-4818337-\$		
		or US-4556790-\$ or US-4555622-\$ or		
		US-4497974-\$ or US-4536608-\$ or US-4493942-\$		
		or US-4482779-\$ or US-4482778-\$ or		
	:	US-4419533-\$ or US-4379944-\$ or US-4377722-\$		
		or US-4350561-\$ or US-4315097-\$ or		
•		US-5792280-\$).did. or (US-20010039101-\$ or		
		U5-20020002992-\$).did. or (WO-9214270-\$).did.		
-	2	((U5-4989972-\$ or U5-6350945-\$ or	USPAT;	2002/03/08
		US-6329296-\$ or US-6091021-\$ or US-6307145-\$	US-PGPUB;	14:16
		or US-5932114-\$ or US-5810945-\$ or	EPO; JPO;	
		US-5492859-\$ or US-5277748-\$ or US-5035770-\$	DERWENT	
		or US-4818337-\$ or US-4556790-\$ or		
		US-4555622-\$ or US-4497974-\$ or US-4536608-\$		
		or US-4493942-\$ or US-4482779-\$ or		
	÷	US-4482778-\$ or US-4419533-\$ or US-4379944-\$		
		or US-4377722-\$ or US-4350561-\$ or		
		US-4315097-\$ or US-5792280-\$).did. or		
		(US-20010039101-\$ or US-20020002992-\$).did. or		
		(WO-9214270-\$).did.) and (surface near damage)		
_	0	6329296.URPN.	USPAT	2002/03/08
	_			14:14
-	3	((US-4989972-\$ or US-6350945-\$ or	USPAT;	2002/03/08
	_	US-6329296-\$ or US-6091021-\$ or US-6307145-\$	US-PGPUB:	14:16
		or US-5932114-\$ or US-5810945-\$ or	EPO; JPO;	
		US-5492859-\$ or US-5277748-\$ or US-5035770-\$	DERWENT	
		or US-4818337-\$ or US-4556790-\$ or		
		US-4555622-\$ or US-4497974-\$ or US-4536608-\$		
		or US-4493942-\$ or US-4482779-\$ or		
		US-4482778-\$ or US-4419533-\$ or US-4379944-\$		
		or US-4377722-\$ or US-4350561-\$ or		
		US-4315097-\$ or US-5792280-\$).did. or		
		(US-20010039101-\$ or US-20020002992-\$).did. or		
		(WO-9214270-\$).did.) and (surface near3 damage)		
L		(170 ) at 12/0 4). and (30) face field 3 daniage)		l

	7	((US-4989972-\$ or US-6350945-\$ or	USPAT;	2002/03/08
-	<b>'</b>	US-6329296-\$ or US-6091021-\$ or US-6307145-\$	US-PGPUB;	14:17
		or US-5932114-\$ or US-5810945-\$ or	EPO; JPO;	47.1/
			DERWENT	
		US-5492859-\$ or US-5277748-\$ or US-5035770-\$	DEKWENT	
		or US-4818337-\$ or US-4556790-\$ or		
		US-4555622-\$ or US-4497974-\$ or US-4536608-\$		
		or US-4493942-\$ or US-4482779-\$ or		
1		US-4482778-\$ or US-4419533-\$ or US-4379944-\$		
		or US-4377722-\$ or US-4350561-\$ or		
		US-4315097-\$ or US-5792280-\$).did. or		
		(U5-20010039101-\$ or U5-20020002992-\$).did. or		
		(WO-9214270-\$).did.) and damage		
-	3	((US-4989972-\$ or US-6350945-\$ or	USPAT;	2002/03/08
		US-6329296-\$ or US-6091021-\$ or US-6307145-\$	U5-PGPUB;	15:03
		or US-5932114-\$ or US-5810945-\$ or	EPO; JPO;	
		US-5492859-\$ or US-5277748-\$ or US-5035770-\$	DERWENT	
		or US-4818337-\$ or US-4556790-\$ or	1	
}		US-4555622-\$ or US-4497974-\$ or US-4536608-\$		
		or US-4493942-\$ or US-4482779-\$ or		
		US-4482778-\$ or US-4419533-\$ or US-4379944-\$		
		or US-4377722-\$ or US-4350561-\$ or		
		US-4315097-\$ or US-5792280-\$).did. or		
i l		(US-20010039101-\$ or US-20020002992-\$).did. or		
		(WO-9214270-\$).did.) and (ion adj implantation) and		
		phosphorous		
_	27	(US-6350945-\$ or US-5810945-\$ or US-4818337-\$	USPAT;	2002/03/08
	,	or US-4536608-\$ or US-4493942-\$ or	US-PGPUB;	15:46
		US-4482779-\$ or US-4482778-\$ or US-4419533-\$	EPO .	100.10
		or US-4379944-\$ or US-6307145-\$ or		
		US-4556790-\$ or US-4555622-\$ or US-4497974-\$		
		or US-4377722-\$ or US-4350561-\$ or		
1		US-4315097-\$ or US-6091021-\$ or US-5932114-\$ or		
		US-5035770-\$ or US-6329296-\$ or US-4989972-\$		
		or US-5792280-\$ or US-5492859-\$ or		
		·		·
1		US-5277748-\$).did. or (US-20010039101-\$ or		
	2.	US-20020002992-\$).did. or (WO-9214270-\$).did.	LICDAT:	2002/02/09
-	26	((US-6350945-\$ or US-5810945-\$ or US-4818337-\$	USPAT;	2002/03/08
		or US-4536608-\$ or US-4493942-\$ or	US-PGPUB;	15:46
		US-4482779-\$ or US-4482778-\$ or US-4419533-\$	EPO; JPO;	
		or US-4379944-\$ or US-6307145-\$ or	DERWENT	
		US-4556790-\$ or US-4555622-\$ or US-4497974-\$		
		or US-4377722-\$ or US-4350561-\$ or		
		US-4315097-\$ or US-6091021-\$ or US-5932114-\$ or		
		US-5035770-\$ or US-6329296-\$ or US-4989972-\$		
		or US-5792280-\$ or US-5492859-\$ or		
		US-5277748-\$).did. or (US-20010039101-\$ or		
		US-20020002992-\$).did. or (WO-9214270-\$).did.)		
1		and thickness		

	24	((US-6350945-\$ or US-5810945-\$ or US-4818337-\$	USPAT;	2002/03/08
-	24	or US-4536608-\$ or US-3610943-\$ or US-4818337-\$	USPAT; US-PGPUB;	15:49
		US-4482779-\$ or US-4482778-\$ or US-4419533-\$	EPO; JPO;	15.49
			DERWENT	
		or US-4379944-\$ or US-6307145-\$ or	DERWENT	
		US-4556790-\$ or US-4555622-\$ or US-4497974-\$		
		or US-4377722-\$ or US-4350561-\$ or		
•		US-4315097-\$ or US-6091021-\$ or US-5932114-\$ or		
		US-5035770-\$ or US-6329296-\$ or US-4989972-\$		
		or US-5792280-\$ or US-5492859-\$ or		
		US-5277748-\$).did. or (US-20010039101-\$ or		
		US-20020002992-\$).did. or (WO-9214270-\$).did.)		
		and thickness and silicon		
-	19	((US-6350945-\$ or US-5810945-\$ or US-4818337-\$	USPAT;	2002/03/08
		or US-4536608-\$ or US-4493942-\$ or	US-PGPUB;	15:49
		US-4482779-\$ or US-4482778-\$ or US-4419533-\$	EPO; JPO;	
		or US-4379944-\$ or US-6307145-\$ or	DERWENT	
		US-4556790-\$ or US-4555622-\$ or US-4497974-\$		
		or US-4377722-\$ or US-4350561-\$ or		
		US-4315097-\$ or US-6091021-\$ or US-5932114-\$ or		
		US-5035770-\$ or US-6329296-\$ or US-4989972-\$		
		or US-5792280-\$ or US-5492859-\$ or		
		US-5277748-\$).did. or (US-20010039101-\$ or		
		US-20020002992-\$).did. or (WO-9214270-\$).did.)		
		and (thickness same silicon)		:
_	17	((US-6350945-\$ or US-5810945-\$ or US-4818337-\$	USPAT;	2002/03/08
		or US-4536608-\$ or US-4493942-\$ or	US-PGPUB;	15:49
		US-4482779-\$ or US-4482778-\$ or US-4419533-\$	EPO; JPO;	15.49
		or US-4379944-\$ or US-6307145-\$ or	DERWENT	
		US-4556790-\$ or US-4555622-\$ or US-4497974-\$	DERWEINT	
		or US-4377722-\$ or US-4350561-\$ or		
		US-4315097-\$ or US-6091021-\$ or US-5932114-\$ or		
		US-5035770-\$ or US-6329296-\$ or US-4989972-\$		
		·		,
		or US-5792280-\$ or US-5492859-\$ or		
		US-5277748-\$).did. or (US-20010039101-\$ or		
		US-20020002992-\$).did. or (WO-9214270-\$).did.)		
		and (thickness with silicon)		
-	1	4419533.pn. and blazed	USPAT;	2002/03/11 11:45
			US-PGPUB;	
			EPO; JPO;	·
			DERWENT	
-	2	5792280.pn. and furnace	USPAT;	2002/03/11
			US-PGPUB;	14:58
			EPO; JPO;	
1			DERWENT	
-	73	136/\$.ccls. and ((grating or diffraction) same order)	USPAT;	2002/08/26
			US-PGPUB;	11:29
			EPO; JPO;	,
	]		DERWENT	
-	10	136/\$.ccls. and ((grating near diffraction) same	USPAT;	2002/08/26
		order)	US-PGPUB;	11:29
	.		EPO; JPO;	
			DERWENT	
	•			

[_	12132	136/\$.ccls.	USPAT;	2003/06/30
		φ	US-PGPUB;	08:44
			EPO; JPO;	
	,		DERWENT;	
			IBM_TDB	
	380	136/\$.ccls. and (diffractive or diffraction)	USPAT;	2003/06/30
		(2,1,1,2,1,1,2,1,1,2,1,1,2,1,1,2,1,1,1,1	US-PGPUB;	08:59
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
_	90	136/\$.ccls. and ((first or second or zero\$3) adj	USPAT;	2003/06/30
		order)	US-PGPUB;	08:44
	1	,	EPO; JPO;	
			DERWENT;	
			IBM_TDB	
_	10	(136/\$.ccls. and (diffractive or diffraction)) and	USPAT;	2003/06/30
		(136/\$.ccls. and ((first or second or third or zero\$3)	US-PGPUB;	08:45
		adjorder))	EPO; JPO;	
			DERWENT;	
			IBM_TDB	
	101	136/\$.ccls. and ((first or second or third or zero\$3)	USPAT;	2003/06/30
		adjorder)	US-PGPUB;	08:53
	i	,	EPO; JPO;	
			DERWENT;	
			IBM_TDB	
-	33	136/\$.ccls. and ((diffractive or diffraction) with	USPAT;	2003/06/30
		order)	US-PGPUB;	10:12
			EPO; JPO;	
	:		DERWENT;	
			IBM_TDB	
_	4	216/58,83.ccls. and (diffraction adj (grate or	USPAT;	2003/06/30
		grating))	US-PGPUB;	10:34
	•		EPO; JPO;	
			DERWENT	
-	163	216/\$.ccls. and (diffraction adj (grate or grating))	USPAT;	2003/06/30
			US-PGPUB;	10:40
			EPO; JPO;	
	}		DERWENT	
-	6	(216/\$.ccls. and (diffraction adj (grate or grating)))	USPAT;	2003/06/30
	-	and (solar or photovoltaic)	US-PGPUB;	10:38
	1		EPO; JPO;	
			DERWENT	
	42	(216/\$.ccls. and (diffraction adj (grate or grating)))	USPAT;	2003/06/30
		and (reactive adj ion adj etch\$3)	U5-PGPUB;	10:41
	1		EPO; JPO;	
			DERWENT	
_	26	216/\$.ccls. and ((diffraction adj (grate or grating))	USPAT;	2003/06/30
		with (transmi\$7 or transparent))	US-PGPUB;	10:41
	1		EPO; JPO;	
			DERWENT	
-	7	(216/\$.ccls. and ((diffraction adj (grate or grating))	USPAT;	2003/06/30
		with (transmi\$7 or transparent))) and (reactive adj	US-PGPUB;	11:25
		ion adj etch\$3)	EPO; JPO;	
			DERWENT	

-	343	136/\$.ccls. and (ion adj implantation)	USPAT;	2003/06/30
		and the control of th	US-PGPUB;	11:25
			EPO; JPO;	*******
		·	DERWENT	
_	41	(136/\$.ccls. and (ion adj implantation)) and	USPAT;	2003/06/30
		(diffraction or diffractive)	U5-PGPUB;	11:25
		, , , , , , , , , , , , , , , , , , , ,	EPO; JPO;	
			DERWENT	
-	3	(136/\$.ccls. and (ion adj implantation)) and	USPAT;	2003/06/30
		((diffraction or diffractive) adj grating)	US-PGPUB;	12:03
		, , , , , , , , , , , , , , , , , , , ,	EPO; JPO;	
			DERWENT	
_	27	136/\$.ccls. and ((rie or (reactive adj ion adj etch\$3))	USPAT;	2003/06/30
		with (contamin\$7 or clean or remov\$3))	US-PGPUB;	12:08
			EPO; JPO;	
			DERWENT	
_	0	216/\$.ccls. and ((rie or (reactive adj ion adj etch\$3))	USPAT;	2003/06/30
1		with (contamin\$7 or clean\$3))	US-PGPUB;	12:08
			EPO; JPO;	
			DERWENT	
-	27	136/\$.ccls. and ((rie or (reactive adj ion adj etch\$3))	USPAT;	2003/06/30
		with (contamin\$7 or clean\$3 or remov\$3))	US-PGPUB;	12:08
			EPO; JPO;	
			DERWENT	
-	93	216/\$.ccls. and ((rie or (reactive adj ion adj etch\$3))	USPAT;	2003/06/30
		with (contamin\$7 or clean\$3))	US-PGPUB;	12:18
İ			EPO; JPO;	
			DERWENT	
-	76	(216/\$.ccls. and ((rie or (reactive adj ion adj	USPAT;	2003/06/30
		etch\$3)) with (contamin\$7 or clean\$3))) and silicon	US-PGPUB;	12:15
			EPO; JPO;	
İ			DERWENT	
-	17	(216/\$.ccls. and ((rie or (reactive adj ion adj	USPAT;	2003/06/30
		etch\$3)) with (contamin\$7 or clean\$3))) not silicon	US-PGPUB;	12:16
			EPO; JPO;	
			DERWENT	
-	76	(216/\$.ccls. and ((rie or (reactive adj ion adj	USPAT;	2003/06/30
		etch\$3)) with (contamin\$7 or clean\$3))) not	US-PGPUB;	12:16
		((216/\$.ccls. and ((rie or (reactive adj ion adj	EPO; JPO;	
	[	etch\$3)) with (contamin\$7 or clean\$3))) not silicon)	DERWENT	
_	0	((216/\$.ccls. and ((rie or (reactive adj ion adj	USPAT;	2003/06/30
		etch\$3)) with (contamin\$7 or clean\$3))) not	US-PGPUB;	12:19
		((216/\$.ccls. and ((rie or (reactive adj ion adj	EPO; JPO;	
		etch\$3)) with (contamin\$7 or clean\$3))) not silicon))	DERWENT	
		and ((clean\$5 or contamin\$7) with ((potassium adj		
	180	hydroxide) or koh! or (wet adj chemical adj etch\$3)))	LICDAT:	2003/07/20
_	160	216/\$.ccls. and ((rie or (reactive adj ion adj etch\$3)) with (contamin\$7 or clean\$3 or damag\$3))	USPAT; US-PGPUB;	2003/06/30 12:19
		with featurinal of cientide of animages))	EPO; JPO;	14.19
	[		DERWENT	
_	33	(216/\$.ccls. and ((rie or (reactive adj ion adj	USPAT;	2003/06/30
	33	etch\$3)) with (contamin\$7 or clean\$3 or damag\$3)))	US-PGPUB;	12:19
		not silicon	EPO; JPO;	12.17
			DERWENT	
L	<u> </u>		OCV AN CLAI	

-	147	(216/\$.ccls. and ((rie or (reactive adj ion adj	USPAT;	2003/06/30
		etch\$3)) with (contamin\$7 or clean\$3 or damag\$3)))	US-PGPUB;	12:19
		not ((216/\$.ccls. and ((rie or (reactive adj ion adj	EPO; JPO;	
		etch\$3)) with (contamin\$7 or clean\$3 or damag\$3)))	DERWENT	
		not silicon)		
_	О	((216/\$.ccls. and ((rie or (reactive adj ion adj	USPAT;	2003/06/30
		etch\$3)) with (contamin\$7 or clean\$3 or damag\$3)))	US-PGPUB;	12:19
	ľ	not ((216/\$.ccls. and ((rie or (reactive adj ion adj	EPO; JPO;	
		etch\$3)) with (contamin\$7 or clean\$3 or damag\$3)))	DERWENT	
		not silicon)) and ((clean\$5 or contamin\$7) with		
		((potassium adj hydroxide) or koh! or (wet adj		
		chemical adj etch\$3)))		
-	2	((216/\$.ccls. and ((rie or (reactive adj ion adj	USPAT;	2003/06/30
		etch\$3)) with (contamin\$7 or clean\$3 or damag\$3)))	US-PGPUB;	12:19
		not ((216/\$.ccls. and ((rie or (reactive adj ion adj	EPO; JPO;	
		etch\$3)) with (contamin\$7 or clean\$3 or damag\$3)))	DERWENT	
		not silicon)) and ((clean\$5 or contamin\$7 or		
		damag\$4) with ((potassium adj hydroxide) or koh! or		
		(wet adj chemical adj etch\$3)))		
-	5	136/\$.ccls. and (grating adj solar adj cell)	USPAT;	2003/06/30
			US-PGPUB;	14:30
			EPO; JPO;	
•			DERWENT	
-	387	136/\$.ccls. and diffraction	USPAT;	2003/10/30
			U5-PGPUB;	14:12
			EPO; JPO;	
			DERWENT;	
	140	4244	IBM_TDB	
-	140	(136/\$.ccls. and diffraction) not (ray adj diffraction)	USPAT;	2003/10/30
	1	,	US-PGPUB;	14:13
			EPO; JPO;	
			DERWENT; IBM_TDB	
1_	1	834308.apn.		2004/02/04
	*	- 00 το 00. αμπ.	USPAT; US-PGPUB;	2004/02/04
			EPO; JPO;	08:47
			DERWENT;	
			IBM_TDB	
-	396	136/\$.ccls. and (diffraction)	USPAT;	2004/03/12
		, Tresier and Carrin admini	US-PGPUB;	10:53
			EPO; JPO;	10.00
			DERWENT	
-	273	(136/\$.ccls. and (diffraction)) and "x-ray"	USPAT;	2004/03/12
			US-PGPUB;	10:32
			EPO; JPO;	
			DERWENT	
-	123	(136/\$.ccls. and (diffraction)) not ((136/\$.ccls. and	USPAT;	2004/03/12
		(diffraction)) and "x-ray")	US-PGPUB;	10:32
			EPO; JPO;	
]			DERWENT	
-	34	438/71,72,57,65.ccls. and grating	USPAT;	2004/03/12
			US-PGPUB;	10:40
	]		EPO; JPO;	
			DERWENT	

-	96	257/436,184,466.ccls. and (grating)	USPAT;	2004/03/12
			US-PGPUB;	10:42
			EPO; JPO;	
			DERWENT	
-	101	136/\$.ccls. and (grating)	USPAT;	2004/03/12
			U5-PGPUB;	10:53
			EPO; JPO;	
			DERWENT	
-	60	(136/\$.ccls. and (grating)) not ((136/\$.ccls. and	USPAT;	2004/03/12
		(diffraction)) not ((136/\$.ccls. and (diffraction)) and	US-PGPUB;	10:53
		"x-ray"))	EPO; JPO;	
		·	DERWENT	